



Docket No.: 204552021700  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Tetsuyoshi INOUE

Application No.: 09/987,010

Confirmation No.: 6384

Filed: November 13, 2001

Art Unit: 2828

For: SEMICONDUCTOR LASER  
MANUFACTURING METHOD AND  
SEMICONDUCTOR LASER

Examiner: T. N. Nguyen

**SUBMISSION OF REPLACEMENT DRAWING**

MS Issue Fee  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313

Dear Sir:

Submitted herewith is 1 sheet (Figures 10A-10C) of replacement drawings for filing in the above-identified patent application. Kindly substitute the enclosed replacement drawing for the drawing submitted with the originally-filed application.

Dated: August 16, 2005

Respectfully submitted,

By Deborah S. Gladstein  
Deborah S. Gladstein

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